

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	201	(ar or argon) same beam same (chlorine or "Cl.sub.2") same etch\$3	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:32
L2	216	(ar or argon) same (beam or irradiat\$3) same (chlorine or "Cl.sub.2") same etch\$3	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:50
L3	6384	(ar or argon) and (beam or irradiat\$3 or laser) and (chlorine or "Cl.sub.2" or etchant) and (chamber or reactor)	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:44
L4	6384	(ar or argon) and (beam or irradiat\$3 or laser) and (chlorine or "Cl.sub.2" or etchant) and (chamber or reactor)	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:37
L5	1318	L4 and "438"/\$.ccls.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:51
L6	81	(ar or argon) same (beam or irradiat\$3 or laser) same (chlorine or "Cl.sub.2" or etchant) same sputter\$3	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:42
L7	5335	(ar or argon) and (beam or irradiat\$3 or laser) and (chlorine or "Cl.sub.2" or etchant) and (ions or species) and (plasma or "dry etched")	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:45
L8	2627	((438/706) or (438/710) or (438/712) or (438/720)).CCLS.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/11/24 12:46
L10	213	7 and 8	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/11/24 12:46
L11	0	geun-young-yeom.in.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/11/24 12:47
L12	2	yeom-geun-young.in.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/11/24 12:48
L13	0	Chung-Min-jae.in.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/11/24 12:48

L14	1	Lee-do-haing.in.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/11/24 12:49
L15	0	Chung-sae-hoon.in.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/11/24 12:49
L16	506	(ar or argon) same (beam or irradiat\$3 or expos\$3) same (chlorine or "Cl.sub.2") same etch\$3	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:50
L17	279	16 and "438"/\$.ccls.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/24 12:51